



41.

GP 17654

PATENT

Docket No.: 4006-150

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Chun-Lien SU ET AL

U.S. Patent Application No. 10/054,962

Filed: January 25, 2002

Group Art Unit: 1765

Examiner: CHEN, KIN CHAN

RECEIVED
OCT 31 2003
TC 1700

For: METHOD FOR CONTROLLING AND MONITORING A CHEMICAL MECHANICAL POLISHING PROCESS

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☐ No additional fee is required.
- ☐ Small entity status of this application has been established.
- ☒ Also attached: Petition for Extension of Time
Replacement Sheet of Drawings

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	10	20	0	x \$ 18 =	\$ 0.00
Independent Claims	2	3	0	x \$ 86 =	\$ 0.00
If multiple claims newly presented, add \$290.00					
Fee for extension of time					110.00
TOTAL FEE DUE					\$110.00

- ☒ A credit card authorization form in the amount of \$110.00 is attached
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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